IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Examiner:

Hideo Nagai

Group Art Unit: 2811

Serial No.: 10/563,268

Confirmation No. 6407

Filed: January 4, 2006

For:

SEMICONDUCTOR LIGHT EMITTING

DEVICE, METHOD OF

MANUFACTURING THE SAME AND

LIGHTING APPARATUS AND

DISPLAY APPARATUS USING THE

SAME

August 8, 2008

Costa Mesa, California 92626

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In an attempt to fully comply with the duty of disclosure set forth in 37 C.F.R. § 1.56 and in conformance with 37 C.F.R. §§ 1.97 and 1.98, applicant wishes to bring to the attention of the U.S. Patent Office the following references, which were found during the prosecution of a corresponding Japanese patent application:

Japanese Publication No. 2003-46124 w/English Abstract Japanese Publication No. 2004-134633 w/English Abstract

A copy of the foreign references and Form PTO-A820 are attached.

The undersigned attorney hereby certifies that each item contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart international application not more than three months prior to filing this statement.

If the Examiner believes that a telephone conference would help further the prosecution of this case, he is respectfully requested to contact the undersigned attorney at the listed telephone number.

Very truly yours,

SNELL & WILMER LLP

Joseph W. Price, Reg. No. 25,124 600 Anton Boulevard, Suite 1400

Costa Mesa, CA 92626-7689

Tel: 714-427-7420 Fax: 714-427-7799